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Enhancement of magnetic properties by nitrogen implantation to Mn-implanted *p*-type GaN

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N and Mn ions were co-implanted into *p*-type GaN and subsequently annealed at 700–900 °C. Compared with Mn-implanted sample, the (Mn+N)-implanted sample revealed a larger ferromagnetic signal. This was attributed to the increase of Ga–Mn magnetic phases. Mn–N compounds, such as $\text{Mn}_6\text{N}_{2.58}$ and Mn_3N_2 , decreased and the resistivity significantly increased, meaning a reduction of N vacancies. It is suggested that enhancement in ferromagnetic properties in the (Mn+N)-implanted GaN originated from the reduction of N vacancies and the increase of Ga–Mn magnetic phases. © 2004 American Institute of Physics. [DOI: 10.1063/1.1647282]

Diluted magnetic semiconductors (DMSs) based on III–V semiconductors, such as GaAs and GaN, can be fabricated by incorporating a high concentration of magnetic ions into III–V semiconductors by molecular-beam epitaxy (MBE) or ion implantation.^{1–5} In particular, it was theoretically suggested that (Ga,Mn)N films with a high Mn concentration (~ 5 at.%) and a high hole concentration ($\sim 10^{20} \text{ cm}^{-3}$) could yield a high T_c (≥ 300 K).⁶ This allows spintronic devices to operate at room temperature. Recently, Mn-doped GaN films showing ferromagnetic behavior above room temperature were grown on sapphire (0001) by MBE.⁵ The ferromagnetic property was also reported in Mn-implanted GaN with subsequent annealing.⁴ However, some phases could be formed in the films due to the low solubility of magnetic ions in GaN, such as ferromagnetic Ga–Mn and ferrimagnetic Mn–N compounds. These precipitates could give a major contribution to the total magnetic moment of the samples. However, the effects of such compounds on magnetic properties were not clear. It was suggested that several Mn–N compounds were responsible for the ferromagnetic behavior of (Ga,Mn)N films.⁷ On the other hand, there were also reports that ferromagnetic properties were attributed to the formation of Ga–Mn compounds.^{4,8} The origin of ferromagnetic properties in GaN-based DMSs is still unclear.

In this work, we investigated microstructural evolutions of Mn- and (Mn+N)-implanted *p*-type GaN as a function of annealing temperature. Synchrotron x-ray diffraction (XRD) and synchrotron radiation photoemission spectroscopy (SRPES) were employed to identify secondary phases and chemical bonding states in the samples. From these, the effects of implanted N ions on magnetic properties in Mn-implanted GaN are discussed.

The GaN films were grown by metalorganic chemical-vapor deposition on a (0001) sapphire substrate. An undoped GaN layer with a thickness of 1 μm was grown, followed by the growth of 1- μm -thick *p*-type GaN doped with Mg. Electrical activation of the grown samples was carried out at 750 °C for 4 min by rapid thermal annealing (RTA) under a N_2 atmosphere. Hall measurements determined that the net hole concentration in the film was $2.5 \times 10^{17} \text{ cm}^{-3}$.

First, the N⁺ ions were implanted at 35 keV to position the ion peak 80 nm from the surface. The Mn⁺ ions were then implanted at 180 keV to place its peak range at the same position as that of the N⁺ ions. Both N and Mn implant dosages were $5 \times 10^{16} \text{ cm}^{-2}$. For reference, GaN samples implanted with only Mn⁺ ions were also prepared. All samples were held at 350 °C during the implantation to avoid amorphization. Subsequent annealing at 700–900 °C for 30 s was performed under a flowing N_2 gas in a face-to-face condition. Magnetization measurement was carried out using a superconducting quantum interference device magnetometer (MPMSXL, Quantum Design Co., Ltd.). For resistivity measurement, the samples were patterned using the transmission line method with $100 \times 50 \mu\text{m}^2$ pads. Ti/Al/Ni/Au (300/1200/400/500 Å) contact was annealed under a N_2 atmosphere at 500 °C for 1 min using RTA.

Figure 1 shows magnetization curves at 10 K for the Mn-implanted and (Mn+N)-implanted samples annealed at 800 °C. The magnetization curves were obtained with the applied field parallel to the plane of the samples. The diamagnetic background of GaN substrate was subtracted. The hysteresis loops of both samples showed clear ferromagnetic behavior. The ferromagnetic signal for the (Mn+N)-implanted sample was stronger than that of the Mn-implanted one. The coercive field (H_C) increased from 40 to 72 Oe and the residual magnetization (M_R) also increased from 1.75×10^{-3} to $7.15 \times 10^{-3} \text{ emu/g}$ by the N implanta-

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FIG. 1. Magnetization curves of magnetic moment for Mn-implanted and (Mn+N)-implanted samples annealed at 800 °C for 30 s. The temperature dependence of the magnetic moment is plotted in the inset. The emu/g indicates the magnetization of the entire sample including the substrate.

tion. The temperature dependence of the magnetic moment is plotted in the inset of Fig. 1. The magnetic moment increased after implanting N ions in the temperature range from 10 K to 300 K. No superparamagnetic property was observed in the film.

Figures 2(a) and 2(b) show XRD profiles of Mn-implanted and (Mn+N)-implanted samples, respectively. As Mn-implanted samples were annealed at 800 °C, a Mn–N compound of $\text{Mn}_6\text{N}_{2.58}$ was produced. When the annealing temperature was increased to 900 °C, the peak intensity of $\text{Mn}_6\text{N}_{2.58}$ increased and a peak corresponding to Mn_3N_2 was observed. On the other hand, no Mn_3N_2 was observed in the (Mn+N)-implanted samples even after annealing at 900 °C. Only a small amount of $\text{Mn}_6\text{N}_{2.58}$ was detected.

Figure 3 displays the SRPES spectra of $\text{Mn } 2p_{3/2}$ and $\text{Ga } 3d$ core levels for Mn- and (Mn+N)-implanted samples with annealing temperature. All samples were *in situ* etched about 50 Å using Ar-ion sputtering to remove surface oxides. For Mn-implanted GaN, the peak in the $\text{Mn } 2p_{3/2}$ spectra in Fig. 3(a) corresponds to a Mn–N bond considering the XRD data in Fig. 2. When the sample was annealed at 800 °C, a peak [▼ in Fig. 3(a)] located at the lower binding energy by about 3.0 eV was found. The change in the height of the peak (▼) in Fig. 3(a) was consistent with the Ga–Mn bond in Fig. 3(b). This suggests that the peak (▼) in Fig. 3(a)

FIG. 2. Change of XRD scans as a function of annealing temperature: (a) Mn-implanted GaN and (b) (Mn+N)-implanted GaN. The incident photon energy of 8 keV ($\lambda = 1.55 \text{ \AA}$) was used in the measurements; (□) GaN, (○) Al_2O_3 , (■) $\text{Mn}_6\text{N}_{2.58}$, (●) Mn_3N_2 .

FIG. 3. SRPES spectra of $\text{Mn } 2p_{3/2}$ and $\text{Ga } 3d$ core levels as a function of annealing temperature: (a) Mn-implanted and (b) (Mn+N)-implanted GaN.

corresponds to the Ga–Mn bond. The Ga–Mn bond in $\text{Ga } 3d$ spectra has been described elsewhere.⁹ The peak intensity for the Ga–Mn bond increased as N ions were implanted. Note that the Ga–Mn bond disappeared in the Mn-implanted GaN after annealing at 900 °C, but was still present in the (Mn+N)-implanted GaN.

The changes of surface band bending of Mn- and (Mn+N)-implanted samples with annealing temperature were observed from the valence-band spectra, as shown in Fig. 4. The Fermi level was determined by linearly extrapolating the sloped region with the base line in the valence-band spectrum of Au foil, defined as the level of zero-binding energy. After annealing at 800 °C, the Fermi level nearly coincides with the valence-band maximum. This is due to the fact that the surface changed into a metallic surface, consistent with the observation of metallic Ga–Mn bonds in Figs. 3(a) and 3(b). When Mn-implanted GaN was annealed at 900 °C, the Fermi level shifted about 0.5 eV toward the conduction band in comparison with the as-implanted sample. This is related to N vacancies produced during annealing¹⁰ because N vacancies act as donors for electrons.¹¹ However, no change of the Fermi level with annealing temperature was found in the (Mn+N)-implanted sample, due to the existence of the metallic Ga–Mn bond up to 900 °C.

The variations of the Ga/N ratio for Mn- and (Mn+N)-implanted samples with annealing temperature were plotted in Figs. 4(a) and 4(b), respectively. The Ga/N ratio was determined from the atomic concentrations of each element,

FIG. 4. Change of valence-band spectra as a function of annealing temperature: (a) Mn-implanted and (b) (Mn+N)-implanted GaN.

TABLE I. Resistivity of Mn- and (Mn+N)-implanted samples as a function of annealing temperature.

Annealing temperature (°C)	Resistivity (Ω cm)	
	Mn implanted	(Mn+N) implanted
700	48.11	387.90
800	8.96	755.07
900	10.37	3814.97

calculated from the integral peak intensities of Ga 3d and N 1s spectra. The ratio measured at a detection angle of $\theta=90^\circ$ in as-implanted samples was set to 1.0 for reference. In the Mn-implanted GaN, the Ga/N increased as annealing temperature increased, indicating the production of a number of N vacancies during annealing. The increase in the Ga/N ratio was more pronounced at lower θ . In the meantime, the Ga/N ratio decreased with annealing temperature for (Mn+N)-implanted GaN. This means that the surface of the (Mn+N)-implanted sample maintains a N-rich condition due to N implantation.

The change of resistivity with annealing temperature is summarized in Table I. Both types of samples are *n* type, attributed to N vacancies generated during implantation and annealing. However, it is clear that the resistivity of (Mn+N)-implanted samples is higher than that of Mn-implanted ones. This may be evidence that production of N vacancies is suppressed by N implantation.

When N ions were implanted in GaN and annealed, the atomic composition in the implanted region changed to a N-rich condition, viz. a decrease of N vacancies [Fig. 5]. Mn impurities in GaN diffused through N vacancies.⁸ Thus, the Mn diffusion could be suppressed in the (Mn+N)-implanted sample, preventing Mn atoms from accumulating to form such precipitates, leading to reduction in the amount of Mn-N compounds, Mn_3N_2 and $\text{Mn}_6\text{N}_{2.58}$ (Fig. 2). This was evident by the decrease of Ga/N ratio in Fig. 5 and the significant increase in resistivity in the (Mn+N)-implanted GaN in Table I. The Mn-N compounds are antiferromagnetic materials with a Néel temperature above 300 K, reducing the

magnetic moment of the Mn-implanted GaN.^{12,13}

The enhancement of magnetic properties by N implantation to Mn-implanted GaN originated from the Ga-Mn bond [Fig. 3(b)], even though such phases were not identified from XRD measurements (Fig. 2). The peak intensity for the Ga-Mn bond increased as N ions were implanted. And the Ga-Mn bond was maintained even after annealing at 900 °C. It was reported that the ferromagnetic behavior of Mn-implanted GaN could be due to the formation of a Mn_3Ga phase.⁴ Thus, it is suggested that the Ga-Mn bond may originate from a binary phase of Ga-Mn. No observation of Ga-Mn phases could be attributed to the nanoscale size and the random orientation. The Ga-Mn phase could also increase hole concentration due to the formation of Ga vacancies, which coupled Mn spins randomly distributed in the GaN film. Consequently, it is proposed that Ga-Mn phases play a critical role in enhancing the ferromagnetism in Mn-implanted GaN and N implantation to the Mn-implanted GaN enhances ferromagnetic properties.

In conclusion, the Ga-Mn magnetic phases contributing to ferromagnetic properties increased as N ions were implanted into GaN. Mn-N compounds, such as $\text{Mn}_6\text{N}_{2.58}$ and Mn_3N_2 , decreased and resistivity significantly increased, indicating a reduction of N vacancies in the films. From this, it is suggested that enhancement in ferromagnetic properties by N implantation originated from the increase of Ga-Mn magnetic phases in Mn-implanted GaN.

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FIG. 5. Change of Ga/N atomic ratio with x-ray detection angle as a function of annealing temperature: (a) Mn-implanted and (b) (Mn+N)-implanted GaN.

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